

<b>Notice of References Cited</b>	Application/Control No. 10/677,158		Applicant(s)/Patent Under Reexamination WANG ET AL.	
	Examiner Patricia A. George		Art Unit 1765	Page 1 of 1

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**NON-PATENT DOCUMENTS**

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	U	Wolf; silicon Processing; Vol. 1, pg 58; para.2 1985; isbn 0-9616721-3-7
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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